



INTERNATIONAL
GEMOLOGICAL
INSTITUTE

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LABORATORY GROWN DIAMOND REPORT

December 25, 2025

IGI Report Number **LG760521587**

Description **LABORATORY GROWN DIAMOND**

Shape and Cutting Style **EMERALD CUT**

Measurements **8.49 X 5.98 X 4.12 MM**

GRADING RESULTS

Carat Weight **2.02 CARATS**

Color Grade **E**

Clarity Grade **VS 1**

ADDITIONAL GRADING INFORMATION

Polish **EXCELLENT**

Symmetry **EXCELLENT**

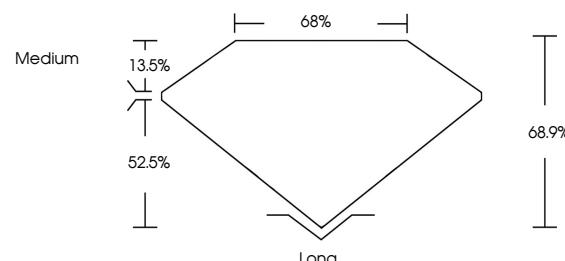
Fluorescence **NONE**

Inscription(s) **IGI LG760521587**

Comments: This Laboratory Grown Diamond was created by Chemical Vapor Deposition (CVD) growth process.

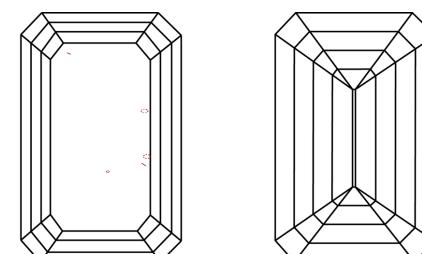
Type IIa

PROPORTIONS



Sample Image Used

CLARITY CHARACTERISTICS



KEY TO SYMBOLS

Red symbols indicate internal characteristics.

Green symbols indicate external characteristics.

www.igi.org

LG760521587
Report verification at igi.org

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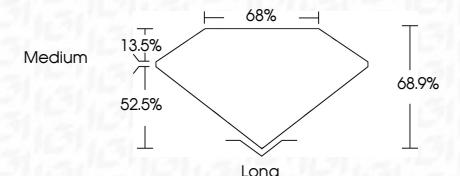
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December 25, 2025	IGI Report No LG760521587	E	2.02 CARATS	EMERALD CUT	8.49 X 5.98 X 4.12 MM	Color Grade	Clarity Grade	Depth	Table	Grade	Culet	Polish	Symmetry	Fluorescence	Inscription(s)
						VS 1	68.9%	68%	68%	Medium	Long	EXCELLENT	EXCELLENT	NONE	IGI LG760521587

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Type IIa